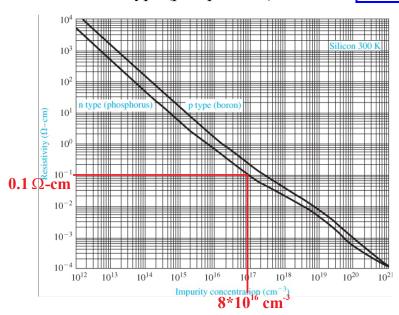
- 5.3 (a) The required conductivity of an n-type silicon sample at T = 300 K is to be $\sigma = 10 (\Omega \text{-cm})^{-1}$. What donor impurity concentration is required? What is the electron mobility corresponding to this impurity concentration? (b) A p-type silicon material is required to have a resistivity of $\rho = 0.20 (\Omega \text{-cm})$. What acceptor impurity concentration is required and what is the corresponding hole mobility?
- a) Per (5.23), $\sigma = e(\mu_n n + \mu_p p)$.

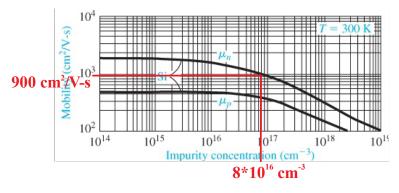
Assume the intrinsic charge concentration, $n_i = 1.5 \times 10^{10} \, \text{#/cm}^3$, (Table B.4) is negligible compared to N_d . So, $n \approx N_d$. Also, assume $N_a = 0$. This gives $\sigma \approx e \, \mu_n N_d$.

Per (5.20), the resistivity is $\rho = 1/\sigma = 1/10 = 0.1 \ \Omega$ ·cm. Using Figure 5.4a, we read that the impurity concentration for *n*-type (phosphorous) should be $N_d = 8 \times 10^{16} \, \text{#/cm}^3$.



From Semiconductor Physics and Devices: Basic Principles (4th Edition), Donald A. Neamen, McGraw Hill, 2012, ISBN 978-0-07-352958-5.

Going to Figure 5.3 (middle graph for silicon), we can read what the electron mobility should be for this impurity concentration. This yields $\mu_n \approx 900 \text{ cm}^2/\text{V-s}$.



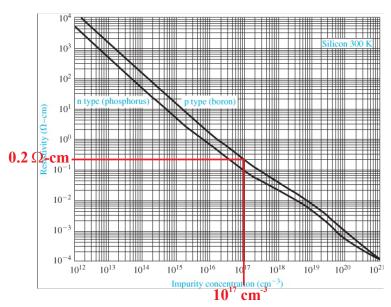
Check- $\sigma \simeq e \,\mu_n N_d = (1.6022 \cdot 10^{-19})(900) \, 8 \cdot 10^{16} \implies \sigma \simeq 11.5 \, \text{S/cm}$. [So-so agreement.]

b) Per (5.23),
$$\sigma = e(\mu_n n + \mu_n p)$$
.

Assume the intrinsic charge concentration, $n_i = 1.5 \times 10^{10} \, \text{#/cm}^3$, (Table B.4) is negligible compared to N_a . So, $p \approx N_a$. Also, assume $N_d = 0$. This gives $\sigma \simeq e \, \mu_p N_a$.

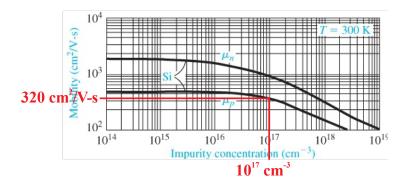
Using Figure 5.4a, we read that the impurity concentration for *p*-type (boron).

$$\Rightarrow N_a = 10^{17} \, \text{\#/cm}^3.$$



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Going to Figure 5.3 (middle graph for silicon), we can read what the hole mobility should be for this impurity concentration. This yields $\mu_p \approx 320 \text{ cm}^2/\text{V-s}$.



Check- $\sigma \simeq e \,\mu_p N_a = (1.6022 \cdot 10^{-19})(320) 10^{17} = 5.13 \,\text{S/cm} \implies \rho \simeq 0.195 \,\Omega \cdot \text{cm}$. Pretty good agreement.